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| | Information Disclosure Statement by Applicant (Use several sheets if necessary) | | |
| | Applicant Rainer Bruchhaus et al. | | Filing Date September 26, 2003 |

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| Examiner Signature  | Date Considered 6/13/05 |
| EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |